

(Use several sheets if necessary)

NEC00P267-hk

09/667,706

Ken Inoue et al.

September 22, 2000

2811

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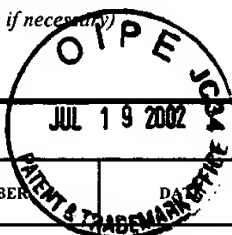
Rough h. Omen

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INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)

NEC00P267-hk

Application Number

09/667,706

Applicant(s)

Ken INOUE et al.

Filing Date

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U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

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FOREIGN PATENT DOCUMENTS

REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
210	10-0190108	01/19/99	KOREA				✓

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

Korean Office Action dated April 29, 2002 with Japanese translation and partial English translation.

EXAMINER

Dough K. Owe

DATE CONSIDERED

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